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L23 and (plasma same (ammonia or "NH.sub.3"))	12

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<u>L26</u>	L23 and (plasma same (ammonia or "NH.sub.3"))	12	<u>L26</u>
<u>L25</u>	L24 and plasma	22	<u>L25</u>
<u>L24</u>	L23 and (plasma or pecvd)	23	<u>L24</u>
<u>L23</u>	L21 and (silicon nitride near2 interface)	23	<u>L23</u>
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<u>L21</u>	L18 and (oxide near8 nitride near8 interface)	98	<u>L21</u>
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<u>L19</u>	L18 and (plasma same nitride near4 interface)	25	<u>L19</u>
<u>L18</u>	L8 and thin film transistor	10870	<u>L18</u>
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<u>L6</u>	(438/\$).ccls.	153168	<u>L6</u>
<i>DB=USPT; PLUR=YES; OP=ADJ</i>			
<u>L5</u>	6045954.pn.	1	<u>L5</u>
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<u>L2</u>	(plasma same nitrid\$ same interface) and ammonia and silane	166	<u>L2</u>
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END OF SEARCH HISTORY